

TITLE OF THE INVENTION

SEMICONDUCTOR RESIN MOLD AND SEMICONDUCTOR RESIN
MOLDING METHOD USING THE MOLD

CROSS-REFERENCE TO RELATED APPLICATIONS

5 This application is based upon and claims the
benefit of priority from the prior Japanese Patent
Application No. 2000-190547, filed June 26, 2000, the
entire contents of which are incorporated herein by
reference.

10 BACKGROUND OF THE INVENTION

 The present invention relates to a semiconductor
resin mold and a semiconductor resin molding method
using the mold, particularly to a resin mold for use in
molding a semiconductor chip mounted on a resin tape
15 substrate having a circuit wiring with a resin on the
resin tape substrate and a semiconductor resin molding
method using the mold.

 In recent years, with size and cost reduction of
an electronic apparatus, a resin molded semiconductor
20 device for use in the electronic apparatus is requested
to be thin and dense, and productivity enhancement
and cost reduction are further required. Instead of
the usual semiconductor device constituted by molding
a semiconductor chip mounted on a lead frame with
25 a resin, a BGA resin molded semiconductor device of
a resin tape type has been developed by mounting
a plurality of semiconductor chips on a resin

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the cavity from the pot through a runner and inflow gate. Thereby, the respective semiconductor chips are altogether molded by the resin on the mount portion of the resin tape substrate, and a resin molded body with the back surface of the resin tape substrate exposed therefrom is formed.

Subsequently, the respective metal ball electrodes are disposed on an external electrode of the circuit wiring exposed to the back surface of the resin tape substrate, and the resin tape substrate is diced to separate individual resin molded semiconductor devices.

As described above, in the resin molding process of the resin molded semiconductor devices using the resin tape substrate, in order to expose the back surface of the resin tape substrate from the molding resin, the back surface of the resin tape substrate needs to be attached fixedly to the attachment area surface of the bottom surface in the cavity of the mold.

Here, since a tape material of the resin tape substrate, adhesive layer for fixing the semiconductor chip, solder resist for protecting and covering the circuit wiring, semiconductor chip, and circuit wiring material are formed of different materials, the materials are different from one another in thermal expansion coefficient. When the materials are heated, for example, at 180°C during molding, the resin tape

substrate warps toward the semiconductor chip because of the difference of the thermal expansion coefficient. Therefore, the resin tape substrate floats above the attachment area surface of the bottom surface of the cavity, and the molten resin charged into the cavity disadvantageously enters to a space between the back surface of the resin tape substrate and the cavity surface.

Since the back surface of the resin tape substrate is covered with the resin entered into the space between the back surface of the resin tape substrate and the cavity surface in this manner, a molding defect occurs in the resin molded body.

Also on the side of the semiconductor chip attached to the upper surface of the resin tape substrate, since the substrate is curved in the cavity, a part of the resin tape substrate disadvantageously contacts, for example, a cavity ceiling portion. Therefore, a portion insufficiently filled with the resin is generated, and the molding defect occurs in the resin molded body. Therefore, a yield of the resin molded semiconductor device is lowered, and productivity is remarkably deteriorated.

BRIEF SUMMARY OF THE INVENTION

According to a first aspect of the present invention, there is provided a semiconductor resin mold comprising:

a resin molding cavity having an attachment surface to which a resin tape substrate with a semiconductor chip mounted thereon is attached; and

5 a plurality of suction holes opened in the attachment surface and connectable to a suction system.

According to the first aspect of the present invention, the resin tape substrate with the semiconductor chip mounted thereon is firmly attached onto the attachment area surface of the bottom surface of the cavity by the suction holes opened in the attachment area surface of the bottom surface of the cavity formed in the mold and connected to the suction system. Therefore, the resin tape substrate can be prevented from warping by heating during resin molding, and the molten resin supplied in the cavity can be prevented from disadvantageously entering to the back surface of the resin tape substrate.

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According to a second aspect of the present invention, there is provided a semiconductor resin molding method of sealing a semiconductor chip mounted on a resin tape substrate with a resin molded body excluding a back surface of the resin tape substrate. The method comprising:

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preparing a mold comprising a cavity having a plurality of suction holes connectable to a suction system in an attachment surface to which the resin tape substrate is attached;

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attaching the resin tape substrate to
the attachment surface of the cavity of the mold;

sucking/fixing the resin tape substrate to the
attachment surface of the cavity after the step of
5 attaching the resin tape substrate to the attachment
surface; and

supplying a resin into the cavity of the mold
after the step of sucking/fixing the resin tape
substrate onto the attachment surface.

10 According to the second aspect of the present
invention, the resin tape substrate with the
semiconductor chip mounted thereon is attached to the
attachment area surface of the bottom surface of the
cavity. After the resin tape substrate is firmly
15 attracted onto the attachment area surface of the
cavity bottom surface by the suction holes opened in
the attachment area surface of the bottom surface of
the cavity, the resin molding is performed. Therefore,
the resin tape substrate can be prevented from warping
20 by heating during resin molding, and the molten resin
supplied in the cavity is prevented from entering to
the back surface of the resin tape substrate. This can
avoid occurrence of a molding defect of the resin
molded body with the resin tape substrate back surface
25 exposed therefrom, and can also prevent the occurrence
of a resin uncharged portion on the side of the
semiconductor chip on the upper surface of the resin

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tape substrate. Therefore, the productivity of the resin molded semiconductor device can remarkably be enhanced.

Additional objects and advantages of the invention will be set forth in the description which follows, and in part will be obvious from the description, or may be learned by practice of the invention. The objects and advantages of the invention may be realized and obtained by means of the instrumentalities and combinations particularly pointed out hereinafter.

BRIEF DESCRIPTION OF THE SEVERAL VIEWS OF THE DRAWING

The accompanying drawings, which are incorporated in and constitute a part of the specification, illustrate presently embodiments of the invention, and together with the general description given above and the detailed description of the embodiments given below, serve to explain the principles of the invention.

FIGS. 1A and 1B are longitudinal and transverse sectional views of a semiconductor resin mold according to a first embodiment of the present invention.

FIG. 1C is a plan view of a resin tape substrate with a semiconductor chip mounted thereon.

FIG. 2 is a plan view showing an attachment area of the resin tape substrate in a lower mold member of the semiconductor resin mold.

FIG. 3 is an enlarged sectional view showing

a resin molded semiconductor device molded with the semiconductor resin mold according to the first aspect of the present invention and diced.

FIG. 4 is a plan view showing that the resin tape substrate is held by a carrier shown in FIG. 1A.

FIG. 5 is a plan view showing the attachment area of the resin tape substrate in the lower mold member of the semiconductor resin mold according to a second embodiment of the present invention.

FIG. 6 is a sectional view taken along a line VI-VI of the lower mold member of the semiconductor resin mold shown in FIG. 5.

FIG. 7 is a sectional view taken along a line VII-VII of the lower mold member of the semiconductor resin mold shown in FIG. 5.

FIG. 8 is a sectional view of the lower mold member for the semiconductor resin mold of FIG. 5 connected to two suction systems.

FIG. 9 is a graph showing a relation between a warping amount of the resin tape substrate and a suction force of the suction system according to the second embodiment of the present invention.

FIG. 10 is a graph showing an operation of two suction systems in the embodiment of FIG. 5.

DETAILED DESCRIPTION OF THE INVENTION

Embodiments of the present invention will be described hereinafter in detail with reference to the

including mount portions such as the circuit wiring 32, semiconductor chip 34, and bonding wire 36 are sealed with a resin molded body 30. Then, the resin molded body 30 is constituted such that the back surface of the resin tape substrate 31 is exposed.

Additionally, after the resin molded body 30 is molded, a metal ball electrode, for example, a solder ball 39 is formed on the end of the external electrode 38.

A plurality of resin molding bodies 30 are simultaneously molded in a transfer mold apparatus (not shown). As shown in FIG. 1A, a mold 1 is attached to a molding section of the transfer mold apparatus.

In FIG. 1A, the mold 1 is constituted of upper and lower mold members 1A and 1B, and is provided with a cavity 2 formed by assembling the members 1A, 1B as shown in FIG. 1A. The cavity 2 is formed mainly by a concave portion formed in the upper mold member 1A, and defined by a space formed between the concave portion and the resin tape substrate 31 laid on the lower mold member 1B. The mold members 1A and 1B are formed of a metal.

A pot P for receiving a resin tablet (not shown) is attached to the upper mold member 1A, and a runner R and inflow gate G are formed in association with the upper mold member 1A so that the runner R and the

inflow gate G are connected to the pot P. The resin tablet in the pot P is heated and a molten resin formed at the pot P flows into the cavity 2 via the runner R and inflow gate G.

5 An attachment area surface for the resin tape substrate 31 is formed in a bottom surface 2A of the cavity 2, that is, the inner surface of the lower mold member 1B, and the resin tape substrate 31 is attached to the attachment area surface.

10 As shown in FIGS. 1A, 1B and FIG. 2, a plurality of suction holes 3 formed in the lower mold member 1B are opened in the attachment area surface of the bottom surface 2A of the cavity 2 to which the resin tape substrate 31 is to be attached.

15 The suction holes 3 are equally arranged in the whole attachment area surface in a matrix fashion in row and column directions. Here, as shown in FIG. 2, three rows of suction holes 3 are formed in a longitudinal direction of the bottom surface 2A of the cavity 2 as the attachment area surface, and
20 a plurality of columns of circular suction holes 3 having substantially the same diameter are opened/arranged in the column direction.

 As shown in FIG. 1A, the plurality of suction
25 holes 3 are connected to a common suction path 3m formed in the lower mold member 1B, and connected to a suction pump S constituting a suction system via

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indicates substantially zero in the suction force of about 130 (Pa).

At this time, the switch SW is opened by the output of the control circuit C, and the suction pump S
5 performs suction based on the control signal of the control circuit C.

Subsequently, the resin tablet in the pot P is heated and molten, the pot P is pressurized by a plunger (not shown) of a transfer mold apparatus,
10 and a molten resin 30A is supplied into the cavity 2 from the pot P via the runner R and inflow gate G.

By this step, the upper surface of the resin tape substrate 31 including the mount portions such as the semiconductor chip 34, bonding wire 36, and circuit
15 wiring 32 is molded with the resin. In this state, since the back surface of the resin tape substrate 31 is fixedly attached/sucked onto the lower mold member 1B, the resin 30A does not flow to the back surface, and the resin molded body 30 with the back surface of
20 the substrate 31 exposed therefrom is molded.

Subsequently, the suction of the suction pump S is stopped by the output of the control circuit C, the switch SW is opened, and the reduced pressure in each of the plurality of suction holes 3 is returned to
25 atmospheric pressure. The stopping of the suction pump S and the opening/closing operation of the switch SW are performed based on the control signal of the

control circuit C.

Subsequently, the resin tape substrate 31 sealed with the resin molded body 30 is extracted from the mold 1, and the metal ball electrodes 39 such as solder balls are formed on the respective external electrodes 38 exposed via the back surface of the resin tape substrate 31, for example, by a known solder dipping process.

Thereafter, the resin molded body 30 is diced and divided into individual pieces, so that the resin molded semiconductor device is completed as shown in FIG. 3.

According to the first embodiment, the following action/effect is obtained.

That is, in the resin mold, a plurality of suction holes 3 connected to the suction pump S are formed to be open in the attachment area surface of the bottom surface 2A of the cavity 2. Thereby, the resin tape substrate 31 with the semiconductor chip 34 mounted thereon is firmly sucked/fixed onto the attachment area surface of the bottom surface 2A of the cavity 2 by the suction holes 3 formed in the attachment area surface of the bottom surface 2A of the cavity 2. Therefore, the resin tape substrate 31 can be prevented from warping by heating during resin molding, and a disadvantage that the resin supplied into the cavity 2 enters to the back surface of the resin tape substrate

31 can be avoided.

Moreover, in the resin molding method, the resin tape substrate 31 with the semiconductor chip 34 mounted thereon is attached to the attachment area surface of the bottom surface 2A of the cavity 2. Subsequently, the resin tape substrate 31 is firmly sucked/fixed onto the attachment area surface of the bottom surface 2A of the cavity 2 by the plurality of suction holes 3 formed in the attachment area surface of the bottom surface 2A of the cavity 2, and the resin molding is performed. This can prevent the resin tape substrate 31 from warping by heating during the resin molding, and therefore the resin supplied into the cavity 2 is prevented from flowing to the back surface of the resin tape substrate 31. Therefore, this can prevent a molding defect of the resin molded body with the back surface of the resin tape substrate 31 exposed therefrom, and a molding defect of the resin molded body because of a resin uncharged portion in the semiconductor chip 34 on the upper surface of the resin tape substrate 31. Additionally, the productivity of the resin molded semiconductor device can remarkably be enhanced.

(Second Embodiment)

A method of manufacturing the resin molded body by the semiconductor resin mold according to a second embodiment of the present invention will be described

with reference to FIG. 5 to FIG. 10. Additionally, the same portions as those of the first embodiment are denoted with the same reference numerals, redundant description is omitted, and only different portions will be described in detail.

In the first embodiment, the openings of a plurality of suction holes 3 are formed in the attachment area surface of the bottom surface 2A of the cavity 2 of the mold 1, and the suction holes 3 are connected to the same suction pump S. On the other hand, in the second embodiment, as shown in FIG. 5, a plurality of first slits 42 are formed in a middle portion of the attachment area surface of a lower mold member 1B-2 constituting the bottom surface 2A of the cavity 2 formed in the mold, and a plurality of second slits 43 are formed in a periphery of the attachment area surface. Since the upper mold member is formed similarly as FIG. 1A, the member is not shown in the second embodiment.

A first suction hole 42a is formed in each first slit 42, and a second suction hole 43a is formed in each second slit 43. Moreover, a plurality of first suction holes 42a are connected to one another via one or more connection path 42b, and subsequently connected to a first suction pump 51 shown in FIG. 8. On the other hand, a plurality of second suction holes 43a are connected to one another via one or more connection

path 43b, and subsequently connected to a suction pump 52 disposed in a second suction system different from that of the first suction pump 51.

That is, as shown in FIG. 5, in the attachment
5 area surface of the bottom surface 2A of the cavity 2, the plurality of first slits 42 elongated in a direction perpendicular to the longitudinal direction of the lower mold member 1B-2 are arranged in parallel with one another at constant intervals in the middle
10 portion of the lower mold member 1B-2. The first suction hole 42a is formed in the bottom surface of the middle portion of each of the plurality of first slits 42. Moreover, as shown in FIG. 7, the first suction holes 42a are connected to one another via one
15 or more connection paths 42b, and connected to the same suction pump 51 of the first suction system.

Here, the first suction holes 42a are divided into three groups positioned in the middle portion and on left and right sides, respectively. The holes
20 of each group are connected to one another via the communication path 42b, and connected to the same first suction pump 51.

Moreover, as shown in FIG. 5, the plurality of second slits 43 elongated in the direction along the
25 longitudinal direction of the lower mold member 1B-2 are linearly arranged at constant intervals above and below (as shown on a drawing sheet) the plurality of

first slits 42. The second suction hole 43a is disposed in the bottom surface of the middle portion of each of the plurality of second slits 43.

Furthermore, as shown in FIG. 6, the second
5 suction holes 43a are connected to one another via one or more communication paths 43b, and connected to the suction pump 52 constituting the second suction system different from the first suction system.

Here, the plurality of second suction holes 43a
10 arranged in the upper side are connected to one another via the upper communication path 43b, the plurality of second suction holes 43a arranged in the lower side are connected to one another via the lower communication path 43b, and these suction holes 43a
15 are connected to the same second pump 53 of the second suction system.

Moreover, the carrier 40 is disposed between the upper mold member 1A and the lower mold member 1B of the mold 1, the resin tape substrate 31 having the
20 semiconductor chips 34 is disposed in the cavity 2, and the back surface of the resin tape substrate 31 is closely attached to the attachment area surface of the bottom surface 2A of the cavity 2.

A molding method using the mold of the second
25 embodiment will next be described.

The first suction pump 51 is first operated by an output of a control circuit C2 of FIG. 8, the air

in the cavity including the space area in the first slit 42b is sucked via the first suction hole 42a to reduce the pressure in the cavity in the mold, and the middle portion of the resin tape substrate 31 excluding the upper and lower portions thereof (as shown on the drawing sheet) is sucked/fixed to the middle portion of the attachment area surface. Thereby, air present between the middle portion of the resin tape substrate 31 and the attachment area surface is pushed out to the peripheral portion of the resin tape substrate 31. As shown by a graph K1 of FIG. 10, a suction state reaches a final suction force of 130 (Pa) in about one second, and subsequently this pressure is kept.

Subsequently, after the middle portion of the resin tape substrate 31 is sucked/fixed, the second suction pump 52 is started by the output of the control circuit C2. The air of the space area in the second slit 43a is sucked by the second suction hole 43b to reduce the pressure in the cavity, and the upper and lower peripheral portions of the resin tape substrate 31 are sucked/fixed to the peripheral portion of the attachment area surface.

A change of the suction force is controlled by the control circuit C2 in the following manner. As shown by a graph K2 of FIG. 10, the pump 52 is driven one second after the pump 51 is driven. When the pressure in the first suction system reaches at

a constant value as indicated by the graph K1, the suction force of the pump 52 rises. Then, the suction force of the pump 52 is stabilized at the same pressure as that of K1 about two seconds after the suction
5 force, so that an inclination of the graph K2 is slightly less than that of the graph K1. That is, the total suction force is stabilized by three seconds after the suction force of graph K1 starts to rise.

Moreover, similarly as the first embodiment, the
10 molten resin 30A is supplied into the cavity 2, the upper surface of the resin tape substrate 31 including the mount portion of the semiconductor chip 34 is molded, and the resin molded body 30 with the back surface of the resin tape substrate 31 exposed
15 therefrom is formed.

Additionally, in the pressure control graph of FIG. 8, the rising inclinations shown by graphs K1 and K2 can be set to substantially the same value.

According to the second embodiment, in addition
20 to the action/effect similar to that of the first embodiment, the following action/effect is obtained.

That is, the plurality of first slits 42 and second slits 43 connected to the suction systems 51, 52, respectively, via the first and second suction
25 holes 42a and 43a are formed in the attachment area surface of the bottom surface 2A of the cavity 2 in the lower mold member 1B-2. In other words, the openings

of the slits 42 and 43 are considered as the enlarged openings of the suction holes 42a and 43a, thereby enlarging the sucking area per one suction hole.

Therefore, as compared with the suction holes 3 of the first embodiment, the whole resin tape substrate 31 can more firmly be sucked/fixed onto the attachment area surface of the bottom surface 2A of the cavity 2.

Therefore, the resin tape substrate 31 can substantially completely be prevented from warping by heating during resin molding, and the molten resin 30A supplied into the cavity 2 can substantially completely be prevented from disadvantageously entering to the back surface of the resin tape substrate 31.

Moreover, in the resin molding method, the back surface of the resin tape substrate 31 can be closely attached to the attachment area surface of the bottom surface 2A of the cavity 2. The first suction system 51 is operated, and the air present between the middle portion of the resin tape substrate 31 and the attachment area surface is first discharged to the peripheral portion of the resin tape substrate 31 by the first slit 42. Then, the middle portion of the resin tape substrate 31 excluding the upper and lower portions is sucked/fixed to the middle portion of the attachment area surface.

Thereafter, the second suction system 52 is operated, and the upper and lower peripheral portions

of the resin tape substrate 31 are sucked/fixed to the peripheral portion of the attachment area surface by the second slit 43.

5 Thereby, the attachment area surface of the bottom surface 2A of the cavity 2 and the back surface of the resin tape substrate 31 can adhere to each other while no air remains therebetween. As a result, the molten resin 30A supplied into the cavity 2 is prevented from flowing to the back surface of the resin tape
10 substrate 31. Therefore, the molding defect of the resin molded body with the back surface of the resin tape substrate 31 exposed therefrom, and the molding defect of the resin molded body by the resin uncharged portion in the semiconductor chip on the upper surface
15 of the resin tape substrate can be prevented. Additionally, the productivity of the resin molded semiconductor device can remarkably be enhanced.

 The present invention is not limited to the aforementioned embodiments, and can variously be
20 modified within the scope of the appended claims.

 For example, in the second embodiment, the second slit 43 is disposed crossing at right angles to the first slit 42. However, all the slits may be disposed in the vertical direction similarly as the first slit,
25 and the length of the slit may substantially be the same in size as the width of the attachment area surface (the width of the vertical direction of the

drawing sheet). In this case, the plurality of slits disposed in left and right outer portions may serve as the second slits, and the plurality of slits in the middle portion held between the second slits may serve as the first slits.

Moreover, in the second embodiment, the first slit 42 is disposed in the direction crossing at right angles to the second slit 43, but the first slit 42 may be disposed in parallel with the second slit 43.

According to the aspect of the semiconductor resin mold of the present invention, the molten resin supplied in the cavity can be prevented from disadvantageously flowing to the back surface of the resin tape substrate.

Furthermore, according to the aspect of the semiconductor resin molding method of the present invention, the molding defect of the resin molded body with the back surface of the resin tape substrate exposed therefrom, and the molding defect of the resin molded body by the resin uncharged portion in the semiconductor chip on the upper surface of the resin tape substrate can be prevented. Additionally, the productivity of the resin molded semiconductor device can remarkably be enhanced.

Additional advantages and modifications will readily occur to those skilled in the art. Therefore, the invention in its broader aspects is not limited to

the specific details and representative embodiments
shown and described herein. Accordingly, various
modifications may be made without departing from the
spirit or scope of the general inventive concept as
5 defined by the appended claims and their equivalents.

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